## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
	: Examiner: Alexander Markoff
MASAAKI SUZUKI	)
	: Group Art Unit: 1746
Div. of Appln. No.: 09/695,925	)
Filed: Herewith	)
	: \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \
For: METHOD OF CLEANING SUBSTRATE	) July 29, 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The present application is a division of co-pending Application No. 09/695,925. This Information Disclosure Statement is filed to make of record all prior art citations found in the parent and all references Applicants deem relevant to the patentability of the presently claimed subject matter.

The concise explanation of relevance for the non-English documents can be

found in the specification, in their respective English language abstracts and in a corresponding

English translation.

**CONCLUSION** 

It is respectfully requested that the above information be considered by the

Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such

information has been considered.

Applicants' undersigned attorney may be reached in our New York office by

telephone at (212) 218-2100. All correspondence should continue to be directed to our below

listed address.

Respectfully submitted,

Attorney for Applicants

Registration No. 12,667

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New York, New York 10112-3801

Facsimile: (212) 218-2200

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Docketing	Client Matter No.: <u>00684.001674.5</u>
Source of IDS Info	ormation
The at	tached Information Disclosure Statement:
	Cites information forwarded in correspondence from the client dated
	Cites information from our in-house inventor search.
X	Other (provide brief explanation).
	References cited in parent.

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APPLICATION NO. ATTY DOCKET NO. FORM PTO 1449 (modified) Div. of 09/695,925 00684.001674.5 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE APPLICANT Masaaki Suzuki LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) GROUP FILING DATE Herewith 1746 U.S. PATENT DOCUMENTS DOCUMENT FILING DATE \*EXAMINER SUBCLASS IF APPROPRIATE CLASS DATE NAME NUMBER INITIAL 2 7/27/82 Shortes et al. 134 4,341,592 5,198,634 3/30/93 Mattson et al. 134 121 5/5/98 Koizumi et al. 438 748 5,747,387 Tanaka 134 1 5,078,832 1/7/92 134 26 12/13/94 Kodama 5,372,651 428 64 5,094,898 3/10/92 Morita et al. 5,215,592 6/1/93 Jackson 134 1 6/7/77 134 1 4,028,135 Vig et al. 748 5.068,040 11/26/91 Jackson 438 12/29/87 62 4,715,392 Abe et al. 134 5,158,100 10/27/92 Tanaka et al. 134 105 5,150,239 9/22/92 Watanabe et al. 359 26 FOREIGN PATENT DOCUMENTS TRANSLATION DOCUMENT DATE COUNTRY CLASS SUBCLASS YES/NO/ OR ABSTRACT NUMBER 1/5/90 02-000315 Japan abstract 63-271938 11/9/88 Japan yes OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.) K.A. Valiev, et al., "Interactions of Short-Wave UV Radiation on Thin Layers of Organic Compounds", Mickroelectronika, vol. 17, no. 6, pp. 522-527 (1988) with abstract. J.R. Vig., "UV/Ozone Cleaning of Surfaces", J. Vac. Sci. Technol., vol. A3, no. 3, Part 1, pp. 1027-1034 (1985).McGraw-Hill Encyclopedia of Physics, S.P. Parker, ed., p. 1135 (1983). L. Zafonte, et al., "UV/Ozone Cleaning for Organics Removal on Silicon Wafers", SPIE vol. 470 Optical Microlithography III: Technology for the Next Decade, pp. 164-175 (1984).

DATE CONSIDERED

**EXAMINER** 

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S)		ATTY DOCKET NO. 00684.001674.5 APPLICATION NO. D			iv. of 09/695,925				
		APPLICANT							
several silects if fiecessary)		FILING DATE Herew	FILING DATE			GROUP 1746			
DOCUMENT NUMBER	DATE	NAME		CLASS	SUBCLASS	FILING DATE IF APPROPRIATE			
6,217,665	4/17/01	Suzuki		134	1				
6,391,117	5/21/02	Suzuki		134	1				
5,071,488	12/10/91	Takayama et al.		134	34				
5,185,059	2/9/93	Nishida et al.		156	659				
FOREIGN PATENT DOCUMENTS									
DOCUMENT NUMBER	DATE	COUNTRY		CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT			
	OTHER DOCUMENT	Γ(S) (Including Author, Title, Date, Pe	rtinent l	Pages, Etc.)					
	DOCUMENT NUMBER  6,217,665  6,391,117  5,071,488  5,185,059	DOCUMENT DATE    DOCUMENT NUMBER   DATE	O0684.001674.5	ARTIMENT OF COMMERCE AND TRADEMARK OFFICE LENCES CITED BY APPLICANT(S) several sheets if necessary)    The comment	00684.001674.5   1	00684.001674.5   Div. of 09/695.5			

DATE CONSIDERED

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